

# Annual Report 2020



#### Publisher

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February 2021

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### 1 Preface

Dear friends of the Institute for Large Area Microelectronics,

Welcome to the first edition of our annual report. This annual report will serve to present our activities in a new, more structured way to our scientific cooperation partners, alumni and all our other friends.

The COVID-19 pandemic and its novel challenges and restrictions dominated events worldwide. At the beginning of the summer semester 2020, the University of Stuttgart had to change within a few weeks from face-to-face to online teaching. Fortunately, we already started some years ago to record lectures and exercises and to make them available to the students via the ILIAS teaching platform. Thus, at least the technical requirements were already available and tested, so that we were able to offer the usual courses in the summer and winter semester. Only the lab course "Fundamentals of Electrical Engineering" had to be postponed as in the entire department of Electrical Engineering and Information Technology. Due to the ongoing COVID-19 situation, the experiment has been converted to an online format so that the last year's group of students is expected to complete this practical course in the summer semester 2021. As the clean room area with dedicated clean room clothing, face mask, gloves and air circulation with particle filter ensures compliance with all hygiene regulations, both the regular "Flat Panel Displays" lab course at the end of the summer semester as well as student works and the research works could proceed almost normally thanks to the extremely disciplined and committed efforts of all employees and students.

Unfortunately, this did not apply to the Eurodisplay conference planned by the institute for the end of September, which had to be postponed by one year due to the pandemic. Considering the current COVID-19 situation it is expected that we might have to postpone again to the end of September 2022. The special benefit of the Eurodisplay is the direct personal exchange between the participants so that a shift is preferred over a purely online conference.

The current research activities are focused on the further development of integrated processes for the production of micromechanical electrical systems and thin film transistors, the realization of active matrix micro-LED and high-resolution actively driven LC modulators for 3-D applications.

Furthermore, the institute participates in the new Research Training Group "Photonics Quantum Engineers" approved at the end of the year by the German Research Group (DFG) with a PhD position in a project for the development of quantum-based gas sensors.

Last year, the long overdue refurbishment of the second inline sputter system was successfully accomplished, so that both machines, which are essential for our research activities, can continue to be operated reliably.

At the beginning of the year Ms. Birgit Schuder started as secretary at the institute and initiated with much enthusiasm numerous new activities, such as this annual report.

I would like to thank all friends of the institute for their support and inspiration and wish you all ongoing good health.

A special thank you to all employees for their tireless commitment ensuring the successful work of the institute on a daily basis. I also sincerely wish you and your families health, happiness and all the best.

Stuttgart, February 2021

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Prof. Dr.-Ing. Norbert Fruehauf

# 2 The Institute

The Institute for Large Area Microelectronics (IGM) is a research and education institute with a major focus on application-oriented research and development of new processes and materials for applications in display technologies.

With its more than 500m<sup>2</sup> of clean room area the Institute of Large Area Microelectronics operates one of the leading independent laboratories for the research and development of thin film electronics and thin film technology (TFTs) as well as their respective fields of application, e.g.:

- Flat panel displays (LCD, OLED)
- Smart Glass
- Optical signal processing
- Micro-electro-mechanical systems (MEMS)

The laboratory has always been focused on application-oriented research and portability to industrial grade production. Therefore, the clean room lab was designed to build complete active matrix LCDs on glass substrates of up to 16 inches squared. This capability to process such (relatively, for a research facility) large substrates gives the laboratory at the Institute for Large Area Microelectronics a unique position in all of Europe.

Besides the extensive research activities of the institute, the university teaching plays an important role. In teaching the institute represents the fundamentals of electrical engineering as well as display and thin film technologies.

# 3 Staff Members

Function	Name	<b>E-mail</b> @igm.uni-stuttgart.de	<b>Phone</b> +49 711 685-
Head of Institute	Prof. DrIng. Norbert Fruehauf	norbert.fruehauf	66922
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Technical Staff	Daniela <b>Schalberger</b> , B.Sc. CTA	daniela.schalberger	69305
	Elisabeth Schuler	elisabeth.schuler	66908
Lecturer	Dr. Hagen <b>Klauk</b> Max-Planck-Institut	hagen.klauk@ fkf.mpg.de	0711/689- 1401

# 4 Teaching

Professor Fruehauf offers lectures on fundamentals of electrical engineering, filter synthesis, optical signal processing, thin film technology and flat panel technology. Several lab courses allow the students to gain some hands-on experience complementing the lectures.

### 4.1 Lectures

All lectures are recorded and uploaded on ILIAS to give the best possible support to the students.

### **Fundamentals of Electrical Engineering I**

Lecturer: Prof. Dr.-Ing. Norbert Fruehauf

Winter semester, 1 semester, 1<sup>st</sup> semester Bachelor's program Electrical Engineering & Information Technology, Mechatronics and Renewable Energies

- Introduction and overview
- Voltage and electric current
- Ohm's Law
- Electric power
- Kirchhoff's Laws
- Network analysis
- Electric field
- Capacities
- Magnetic field
- Induction Law

### Fundamentals of Electrical Engineering II

Lecturer: Prof. Dr.-Ing. Norbert Fruehauf

Summer semester, 1 semester, 2<sup>nd</sup> semester Bachelor's program Electrical Engineering & Information Technology, Mechatronics and Renewable Energies

- Inductances
- Sinusoidally alternating quantities
- Circuits at alternating currents
- General two-poles
- Modulated sources
- Resonant circuits

The two-semester module "Fundamentals of Electrical Engineering" consists of:

- Weekly lecturers
- Bi-weekly lecture exercises
- Bi-weekly group exercises (Electrical Engineering & Information Technology B.Sc. and Renewable Energies B.Sc.: winter semester compulsory, Mechatronics B.Sc.: winter **and** summer semester compulsory)
- Lab course "Fundamentals of Electrical Engineering" (compulsory)

#### Important notice:

The module examination "Fundamentals of Electrical Engineering" is a middegree exam of Electrical Engineering and Information Technology B.Sc. The right for examination expires if the mid-degree exam is not passed until beginning of the 4th semester (inclusive a written retry).

### Filter Synthesis

Lecturer: Prof. Dr.-Ing. Norbert Fruehauf

Winter semester, 1 semester, Master's program

- Introduction
- Mathematics foundations
- RLC-Two-Poles
- Realization of filters
- Transformation of RLC-circuits into active RC-circuits
- Synthesis of reactance four-poles
- RC-active circuits
- Synthesis of distributed circuits of grade two
- Empfindlichkeitstheorie
- Optimization of distributed circuits
- Switched Capacitor Filter

### **Thin Film Technology**

Lecturer: Prof. Dr.-Ing. Norbert Fruehauf

Winter semester, 1 semester, Master's program. This lecture is only available in English.

- Introduction and overview
- Vacuum thin film technology: vacuum technology, vapor deposition, sputtering, plasma deposition, growth and properties of thin films
- Non-vacuum deposition: spin coating, printing, chemical deposition
- Materials for substrates and surface treatment
- Structuring of thin films
- Metrology

### Flat Panel Displays

Lecturer: Prof. Dr.-Ing. Norbert Fruehauf

Summer semester, 1 semester, Electrical Engineering and Information Technology B.Sc. / Photonic Engineering M.Sc.

- Overview: cathode ray tubes, flat panel display technologies, current technologies
- Physiology of sight: color theory, CIE 1931 color space, color filters
- Fundamentals of liquid crystal technology: electro-mechanical properties, variation of the potential energy, twisted and non-twisted lc cells
- Light propagation in optically anisotropic uni-axial media: Jones vectors, Jones matrices
- Liquid crystal technologies: optical transmission through the Fréedericksz cell, vertically aligned and twisted nematic lc cells, surface stabilized ferro electric lc cells
- Control of Ic cells: direct addressing, passiv matrix, active matrix

### **Optical Signal Processing**

Lecturer: Prof. Dr.-Ing. Norbert Fruehauf

Summer semester, 1 semester, Master's program. This lecture is only offered in English.

- Mathematic description of optical signals and optical systems
- Analogue optical signal processing: Fourier-transformation of optical signals, optical filters
- Optical storage: CD, DVD, Blu-Ray, holography
- Optical sensors
- Digital optical signal processing

### **Organic Transistors**

Lecturer: Dr. Hagen Klauk

Winter semester, 1 semester

- Overview: applications for organic transistors, economical considerations, realizations and general properties of organic transistors
- Electronic properties of conjugated carbohydrates: localized and delocalized molecular orbitals, energy of orbitals
- Electronic properties of organic solid state structures: crystalline structure, diesperion, charge transport in partially crystalline layers
- Structure and implementation of organic transistors: selection of materials, stack and processing
- Functionality of organic transistors: channel, carrier injection, band model, analytical description of the characteristics
- Frequency dependence of organic transistors: analysis and optimization of the frequency limit
- Applications for organic transistors: flat panel displays, integrated circuits

### 4.2 Exercises

#### Fundamentals of Electrical Engineering I and II – Lecture Exercises

Contact person: Dr. Ing. Patrick Schalberger Winter and summer semester, 2 semesters, Bachelor's program

#### Fundamentals of Electrical Engineering I and II – Group Exercises

Contact person: Dr. Ing. Patrick Schalberger Winter and summer semester, Bachelor's program Winter semester compulsory for Electrical Engineering & Information Technology B.Sc. and Renewable Energies B.Sc. Winter **and** summer semester compulsory for Mechatronics B.Sc.

#### **Flat Panel Displays Exercises**

Contact person: Annika Schmekal, M.Sc. Summer semester, 1 semester, Electrical Engineering & Information Technology B.Sc. and Photonic Engineering M.Sc.

#### **Filter Synthesis Exercises**

Contact person: Dipl.-Ing. Christiane Reinert-Weiss Winter semester, 1 semester, Master's program

### **Thin Film Technology Exercises**

Contact person: Florian Kleber, M.Sc. Winter semester, 1 semester, Master's program The exercises are only available in English

#### **Optical Signal Processing Exercises**

Contact person: Dipl.-Phys. Marc Wilke Summer semester, 1 semester, Master's program The exercises are only offered in English

### 4.3 Lab Courses

### Lab Course "Fundamentals of Electrical Engineering"

The lab course is an inter-institutional course. It normally takes place in the second semester (summer semester) but had to be postponed due to the ongoing COVID-19 situation. It is compulsory for Electrical Engineering and Information Technology B.Sc. and for Renewable Energies B.Sc.

In addition to demonstrating and reinforcing basic concepts of electrical engineering, including "capacities as blocks to direct currents", "basic circuits with transistors", and "simple voltage dividers using resistors", the experiment "transistor-based amplifier" in the lab course is designed to teach practical experience in the implementation and testing of an amplifier cuircuit using bipolar transistors. The students will build the circuit, expanding it step by step and testing the behavior. The resulting circuit will feature a photo-transistor to create a infrared receiver. Using a transmission circuit also built during the experiment, an audio signal can be transmitted wireless.

### Advanced Lab Course "Flat Panel Displays"

The lab course is part of the Master's program and takes place as an oneweek block course during the first week after the end of lecture period in the summer semester.

This lab course "Flat Panel Displays" focuses on the building of a display for a digital clock. This display is based on a seven-segment display with liquid crystals, polarizers, implemented on glass substrates. All processing steps, including sputtering ITO, spin coating with photo resist and poluimide, photo lithography, wet chemical structuring, and cell construction are performed by the participants in the clean room at the Institute for Large Area Microelectronics. Finally, the display is connected to an IC to form a simple alarm clock. The participants can retain the clock they have built.

### Advanced Lab Course "Optical Signal Processing"

The lab course "Optical Signal Processing" is part of the Master's program and takes place in the winter semester during the lecture period. Students will perform experiments on topics including:

- Spatial and temporal coherence
- Collimation (homogenous plane waves)
- Imaging and Refraction
- Diffraction
- Fourier Optics
- Design and production of synthetic holograms

### 4.4 Degrees

The following Bachelor's and Master's theses were successfully passed in 2020:

### **Bachelor's theses**

#### Florian Werner

Optimization of the deposition parameters of IGZO for TFT application

### Linfei Mao

Investigation of Methods for Parallel Manufacture of IGZO-TFTs and MEMS

### **Master's thesis**

Zenghui Zuo Liquid Crystal Fabry Pérot Interferometer

### 5 **Projects and Research Activities**

Most research activities are third party funded. In addition to federal and European research grants, close cooperations with numerous industrial partners in Germany, Europe, but also in North America and Asia are important sources for funding and projects. Especially German companies profit from the extensive research activities at the Institute for Large Area Microelectronics allowing them to build their own know-how in the field of flat panel displays in a field that is otherwise dominated by companies from Asia.

### 6 Invited Talks and Conferences

#### August 2-7, 2020: SID Display Week, USA

Participation at the SID Display Week which was held as an online virtual conference in San José, USA.

#### September 2, 2020: Online-plenary discussion at AM-FPD '20, Japan

Prof. Fruehauf chaired an online-plenary discussion on the topic "Current Trends in Automotive-Displays". The conference in Japan took place from 1st to 4th September 2020 as an online virtual meeting due to COVID-19.

#### October 14, 2020: Invited online-talk at ICDT 2020, China

Prof. Fruehauf gave an invited online-presentation at ICDT (International Conference on Display Technology) entitled "Characterization of Co-Fabricated Silicon TFT and MEMS Shutter Display". The event was held from 11th to 14th October 2020 as an online virtual conference in Wuhan/China.

# 7 **Publications**

### Conferences

Norbert Fruehauf, Sheikh Abdullah Al Nusayer, Patrick Schalberger, Holger Baur, Clemens Jurgschat

"Characterization of Co-Fabricated Silicon TFT and MEMS Shutter Display" ICDT 2020, China

# 8 Contribution to Organizations

- Chairman of the Board of Curators, Eduard-Rhein-Foundation, Germany
- Member of the Board of Curators, Institute for Microelectronics Stuttgart (IMS), Germany
- General Chair Eurodisplay 2021, SID Society of Information Display
- Member Active Matrix Committee, SID Society of Information Display
- Associate Editor, Journal of the Society of Information Display (JSID)
- Program Committee Member, AM-FPD, Japan
- Overseas Advisor, International Display Workshop (IDW), Japan

# 9 The Clean Room

The Institute for Large Area Microelectronics (IGM) possesses one of the largest university-based clean rooms for flat screen displays and similar systems in the world.

The facilities at the IGM include more than  $500m^2$  clean room space. The majority of that area or about  $480m^2$  are the main lab with a very high purity class for a research fertility (ISO5, less than 100 particles with a size of more than 0,5µm per cubic foot of air; ISO 4, less than 10 particles with a size of more than 0,5µm per cubic foot of air, in the area with the lithographic devices). The IGM is fully equipped to produce flat screens and similar thin film devices in near-industrial processes. The close similarity of the equipment and processes to industrial facility supports the technology transfer to industrial production lines.

A second, smaller clean room contains 3 MBraun glove boxes with a nitrogen inert atmosphere for the processing of organic semiconductors which are very sensitive to oxygen and humidity.

The following devices and facilities are available at the IGM:

### Layer Deposition

- PECVD: The IGM features several PECVD reactors, including one Balzers (Oerlikon) KAI 1M reactor for the deposition of amorphous or polycrystalline silicon (including doping), silicon nitrate, and silicon oxide on glass substrates up to 16 inches squared.
- **Sputtering:** Two Leybold ZV6000 inline-sputtering systems equipped with a total of 12 different targets (9 DC and 3 RF) are available at the IGM. Targets for typical display materials like chromium, aluminium, molydaenium but also gold, nickel, palladium, ITO, AZO, IGZO are available. Numerous additional targets can be mounted as necessary. The sputter system can handle substrates of up to 16 inches squared.

The first ZV6000 sputtering-system had been fundamentally refurbished in 2017. In 2020, together with the company HS-Group GmbH, we had been able to perform the modernization of the second sputtering-system as well. Now, both systems are state-of-the-art regarding to PLC system control, user interface, gasflow control, pressure measurement/-control and substrate transport drive. This enables new possibilities for deposition process optimization and allows for a long term perspective of operating the machines.

- Vapor Deposition: The IGM offers access to a Lesker Spectros vapor deposition system with two separate sources for metallic material and eight sources for organic material. The system is integrated into the inertgas glove boxes to enable oxygen and moisture free handling of OTFTs and OLEDs. In addition, the IGM features two older Balzers systems with thermal and electron beam vaporization systems. All vapor deposition systems can handle substrates of up to 6 inches squared.
- **Spin Coating:** The IGM operates several spin coaters for the deposition of photo resist and other liquids onto substrates of up to 16 inch squared. One smaller spin coater for substrates of up to 6 inches squared is integrated into the inert-gas glove boxes.
- **Printing:** Several printers for the direct deposition of structured layers are accessible at the IGM. Screen printers allow the large area deposition of material at a high volume but require a specifically made screen as a mask. A Dimatix inkjet printer can deposit almost any solution or suspension without the need for a complex physical mask.

### Photo Lithography

- Lithography with Photo Masks: The IGM is equipped with two contact exposure systems of type Süss MA6 for processing substrates of up to 6 inches squared. This allows for the realization of structures down to 3µm.
- **Direct Imaging:** The IGM features a Heidelberg Instruments DWL 400 direct imaging system that can realize structures down to 2µm on 16 inch squared substrates without requiring complex photo masks.

### Layer Modification

- Ion Implantation: Access to an ion implantor type Eaton (Axcelis) NV3206 is offered at the IGM. The standard airlock has been replaced with a larger one allowing the processing of substrates up to 16 inches squared. The system can implant phosphorus, boron, fluor, and argon ions at up to 200kV.
- Excimer-Laser: A Sopra VEL Excimer Laser for the recrystallization of amorphous into polycrystalline silicon is available at the IGM. The XeCl laser operates at a wavelength of 308nm and can fire 200ns pulses of up to 15J each at a target area of 67mm by 27mm. It can also be used to activate doping or to improve the crystal quality of other semiconductors.

The system can process substrates of up to 16 inches squared using stitching.

• UV-Ozone Treatment: The IGM features a UV-Ozone system to clean substrates or to improve surface adhesion. The combination of highly reactive ozone and high energy light can remove organic contaminants and can activate the surface by freeing chemical bonds in surface molecules. The system can process substrates of up to 16 inches squared.

### Liquid Crystal Technology

- **Rubbing:** The IGM offers access a Hörnell Rubbing system to structure the polyimide orientation layer by rubbing with a velvet roll.
- Spacer Spray System: The IGM operates an electrostatic spacer spray system type Accudyne for 5µm spherical polymer spacer used to ensure a uniform thickness of the liquid crystal cell. Additional different sizes of spacers can be sprayed or spin coated.
- **Glue Robot:** A Schiller 3-axis (xyz) gantry robot is used to apply glue frames in the assembly of the two substrates into one liquid crystal cell.
- **Filling Chamber:** The IGM utilizes a dedicated Balzers vacuum chamber with a movable substrate holder to fill cells with liquid crystals.
- **Cell Construction:** The IGM featurs a wide array of additional tools supporting the micrometer alignment of sustrates.

All of the above systems can handle substrates of up to 16 inches squared.

### Metrology

- Waferprober: A Süss wafer prober in combination with a Keithley 4100 semi conductor measurement system allows for the reliable characterization of TFTs and other semiconductor electronic elements. Additional picoampere meters allow measurements in the clean room, in climate boxes and in intert-gas boxes.
- Viewing Angle Contrast Measuremen: An Eldim EZ Contrast 160 system is used for high-speed measurements of luminance, contrast and color space of transmissive and reflective or self-illuminating displays both in absolute values and their viewing angle dependency.
- **Climate Chamber:** A climate chamber allows for the controlled exposure to precisely definite environments, facilitating the evaluation of systems under different conditions and the simulated aging at increased environmental temperatures.

- **Optical Microscopes:** Several optical microscopes allow for quick inspections of processed substrates. Substrates of up to 16 inches squared can be checked.
- Scanning Electron Microscope: For inspections at resolutions above the limits of optical microscopes the IGM features a JEOL JSM 6100 SEM. This system has been modified for digital image generation.
- Atomic Force Microscope: The IGM features a DME AFM to determine surface topologies and surface roughness of layers.

### Bonding

- **TAB Bonder:** Several TAB (Tape Automated Bonding) devices, both manual and semi-automatic, are available for bonding chips on foil (COF) driver chips onto glas substrates using anisotropically conductive adhesive film.
- Flip-Chip Bonder: Unmounted silicon chips can be bonded upside-down (flip-chip) directly onto display glas. This technique saves space on the substrate and is therefore well suited to tablet and smartphone displays. The IGM operates a Süss flip-chip bonder.

## **10 IGM-Activities**

### 10.1 Eurodisplay 2020

The Eurodisplay is Europe's most important scientific conference on information displays and related topics attracting scientists and engineers from all over the world.

Due to COVID-19 the Eurodisplay 2020 has been postponed by one year. The <u>Eurodisplay 2021</u> will take place from 22nd to 24th September 2021 in Stuttgart-Vaihingen, Germany at the campus of the University of Stuttgart.

### **10.2 Trade Fair Trips**

January 29, 2020: Visit of the trade fair "Lounges 2020" in Karlsruhe The 200 exhibitors showcased a wide range of topics, such as Industry/ Pharmaceuticals/Clean Room 4.0, digitization and automation in processes, artificial intelligence, new guidelines and standards as well as sustainability. "Lounges" is the biggest and most important trade fair – also internationally – for the cleanroom sector so that our staff members gained a lot of new insights.

# February 27, 2020: Trip to the trade fair "Embedded World 2020" in Nuremberg

Several staff members visited the trade fair "Embedded World" in Nuremberg. Despite the fact that various exhibitors cancelled their participation due to COVID-19, more than 900 exhibitors from 42 countries presented the entire value chain around Embedded-System-Technologies. As in the past, there was a broad offer ranging from software and hardware, tools, services and systems to system and application software. A special focus was put on solutions in the area of artificial intelligence.

### 10.3 Girls' Day

The Girls' Day on March 26, 2020 has been cancelled due to COVID-19.

### 10.4 Science Day

The Science Day on May 16, 2020 has been cancelled due to COVID-19.

### 10.5 Institute Outing

The annual institute outing is postponed to next year due to COVID-19.

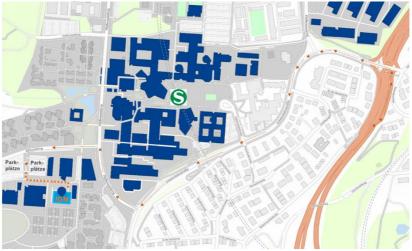
### **10.6 Christmas Party**

The Christmas Party could not take place due to COVID-19.

# **11 Directions and Maps**

### By car

Leave the highway "Autobahn A8" at the interchange "Autobahnkreuz Stuttgart-Vaihingen" and take the A831 / B14 in the direction of Vaihingen. Leave the B14 after the tunnel (careful: speed trap!) at the exit "Universität". At the traffic light turn left. Stay on "Universitätsstrasse" and later turn right into "Pfaffenwaldring". Then turn left into "Allmandring". Take the first entrance on the left and park your car on the university parking place. Now you only need to walk a few steps to the Institute of Large Area Microelectronics (IGM).



Map 1: by car to the Institute of Large Area Microelectronics

### By public transport

Upon arrival at Stuttgart Main Station move towards the lower platforms (S-Bahn, green "S" as a logo). If you do not have a valid ticket for the S-Bahn to "Universität/University" you will need to get a ticket at one of the red ticket machines located near the top of the escalators down to the lower platforms. You will need a one-zone ticket. Choose your language, press the "VVS button" and then "1 zone". You will now be asked to choose between a "single-ticket" (one-way ticket) or a "4-journey-ticket" (multi-ticket usable for four trips). The "4-journey-ticket" has to be devalued before entering the train (small orange boxes).

Take one of the below S-Bahn trains at platform 101:

- S1 direction Herrenberg
- S2 direction Filderstadt
- S3 direction Flughafen

The S-Bahn comes every 5 to 20 minutes, depending on the time of day. Alight at the stop "Universitiät/University" (about 10 minutes trip) and follow the way from the S-Bahn station to the Institute for Large Area Microelectronics (IGM). <u>Please find a detailed way description on our website.</u>

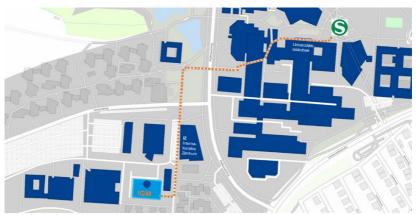
### By plane

Upon arrival at the Stuttgart Airport you will exit the gate on level 1 (lower level). Go to the S-Bahn train station one level lower, marked with a large, green "S" logo. You will need to get a ticket at one of the red ticket machines located near the top of the escalators down to the lower platforms. You will need a two-zone ticket. Choose your language, press the "VVS button" and then "2 zones". You will now be asked to choose between a "single-ticket" (one-way ticket) or a "4-journey-ticket" (multi-ticket usable for four trips). The "4-journey-ticket" has to be devalued before entering the train (small orange boxes).

Take one of the below S-Bahn trains

- S2 direction Schorndorf
- S3 direction Backnang

and exit at S-Bahn station "Universitiät/University" (about 17 minutes trip). Then follow the way to the Institute for Large Area Microelectronics (IGM). Please find a detailed way description on our website.



Map 2: sidewalk from S-Bahn station University to IGM

# 12 Contact

You can contact us at:

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